



AMAT Docket No. 2616 US/RTP/LF
BSTZ Docket No. 004887.P090

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Guangcai Xing, et al.

Application No. 09/298,064

Filed: April 22, 1999

For: APPARATUS AND METHOD FOR EXPOSING A
SUBSTRATE TO PLASMA RADICALS

Examiner: Zervigon, R.

Art Unit: 1763

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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JAN 10 2002

TC 1700

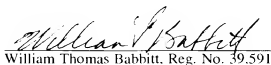
Applicants respectfully petition the Commissioner for a two (2) month extension of time, extending the period for response to November 4, 2001, from the Final Office Action dated June 4, 2001. Applicants previously petitioned for a one month extension of time with the response filed September 24, 2001. Our check in the amount of \$290.00 to cover the balance due for the petition fee and the Notice of Appeal are submitted herewith.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional amount due to Deposit Account 02-2666. A duplicate of the Fee Transmittal sheet is submitted herewith for charging purposes.

Respectfully submitted,

BLAKELY SOKOLOFF TAYLOR & ZAFMAN

Date: 11/5/01


William Thomas Babbitt, Reg. No. 39,591

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CERTIFICATE OF MAILING:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on November 5, 2001.

WTB/ndc

Nedy Calderon

Date